



Sheet 1 of 12

Form PTO-1449 <i>(Substitute)</i>				Attorney Docket Number LAZE-01000US0 SRM/MLR		Serial/Patent Number 09/465,592	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use several sheets if necessary)</i>				Applicant/Patent Owner Culver, Rust			
				Filing/Issue Date 12/17/99	Group Art Unit 2653		
U.S. PATENTS							
Examiner Initial		Patent Number	Issue Date	First Named Inventor	Class	Subclass	Filing Date
U.S. PATENT PUBLICATIONS							
Examiner Initial		Patent Application Publication Number		Publication Date	Applicant		
PENDING U.S. PATENT APPLICATIONS							
Examiner Initial		Application Number	Filing Date	First Named Inventor		Petition to Expunge? Yes No	
OTHER DOCUMENTS (Include author (if any), title, publisher and place of publication, date and pertinent pages)							
<i>bc</i>	1.	Eleftherious, E., et al., "Millipede - A MEMS-Based Scanning-Probe Data-Storage System," IEEE Transactions on Magnetics, Vol. 39, No. 2, March 2003, pp. 938-945.					
<i>bc</i>	2.	Kado, H. and Tohda, T., "Nanometer-scale recording on chalcogenide films with an atomic force microscope," Appl. Phys./Lett., Vol. 66, No. 22, 29 May 1995, pp. 2961-2962.					
<i>bc</i>	3.	Yano, K., et al., "Nanometer scale conductance change in a Langmuir-Blodgett film with the atomic force microscope," Appl. Phys. Lett., Vol. 68, Vol. 2, 8 January 1996, pp. 188-190.					
<i>bc</i>	4.	Yano, K. and Ikeda, T., "Stable bit formation in polyimide Langmuir-Blodgett film using an atomic force microscope," Appl. Phys. Lett., Vol. 80, Vol. 6, 11 February 2002, pp. 1067-1069.					
Examiner	<i>Vin</i> <i>Chen</i>			Date Considered	<i>9/22/03</i>		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							
*1 = Copy not submitted because it was submitted in prior application SN <u>/</u> , filed <u>,</u> 20 <u>,</u> relied on under 35 USC §120. *2 = Copy not submitted because it was submitted in prior application SN <u>/</u> , filed <u>,</u> 20 <u>,</u> relied on under 35 USC §120.							

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